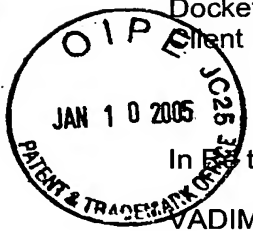


IFW

Docket Number: 081468-0307456

PATENT APPLICATION

Client Reference: P-1794.000-US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of

VADIM YEVGENYEVICH BANINE, et al.

Group Art Unit: 2881

Application No.: 10/747,613

Examiner:

Filed: December 30, 2003

Confirmation No.:

For: LITHOGRAPHIC APPARATUS AND RADIATION SOURCE COMPRISING A
DEBRIS-MITIGATION SYSTEM AND METHOD FOR MITIGATING DEBRIS PARTICLES IN A
LITHOGRAPHIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO/SB/08a. A copy of the reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom. Applicants respectfully request the Examiner return an initialed copy of the enclosed Form PTO/SB/08a to Applicants with the next Office communication to indicate that the reference has been considered, per MPEP § 609.

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

A handwritten signature in black ink, appearing to read "Emily T. Bell".

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